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T. Steptu  
5-27-03

PATENT  
Atty. File No: 83975

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re U.S. Patent Application

) Confirmation No. 4414

Applicant: Satoshi Kitagawa

) Group Art Unit: 2876

Serial No.: 09/696,117

) I hereby certify that this correspondence is  
) being deposited with the United Postal Service  
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) Mail Stop RCE, Commissioner for Patents,  
) P.O. Box 1450, Alexandria, VA, 22313-1450,  
) on May 14, 2003

Filed: October 25, 2000

For: MARKING METHOD FOR SEMICONDUCTOR  
WAFER

Examiner: Lisa M. Caputo

)   
) Daniel M. Gurfinkel, Reg. No. 34,177

REPLY AND AMENDMENT AFTER FINAL

Mail Stop BOX RCE  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

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MAY 21 2003  
TECHNOLOGY CENTER 2800

Dear Sir:

In response to the Office Action dated January 14, 2003, please amend the above-identified application as follows: